

Ad-layers enhance graphene's performance

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Figures

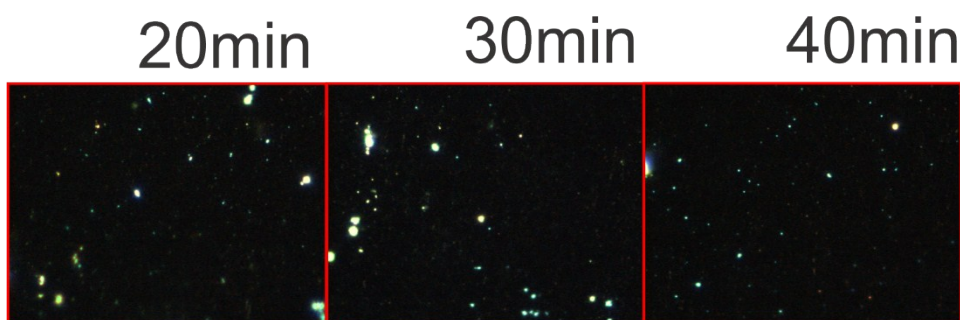


Figure S1. Effect of electropolishing on catalyst morphology: (a, b, c) Dark field Optical micrographs of Cu foil after 20, 30 and 40 minutes electropolishing.

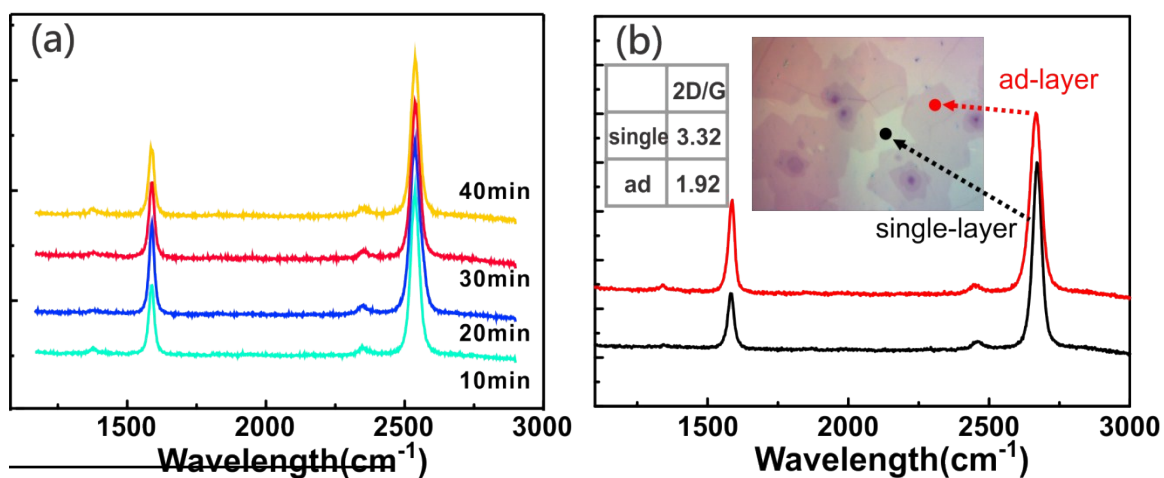


Figure S2. (a) Raman spectra of graphene transferred from graphene/Cu grown with Cu foil electropolished with 10, 20, 30 and 40 minutes. (b) Raman spectra of two specific points within an OM image, (inset) table with averaged I_{2D}/I_G ratio for both positions

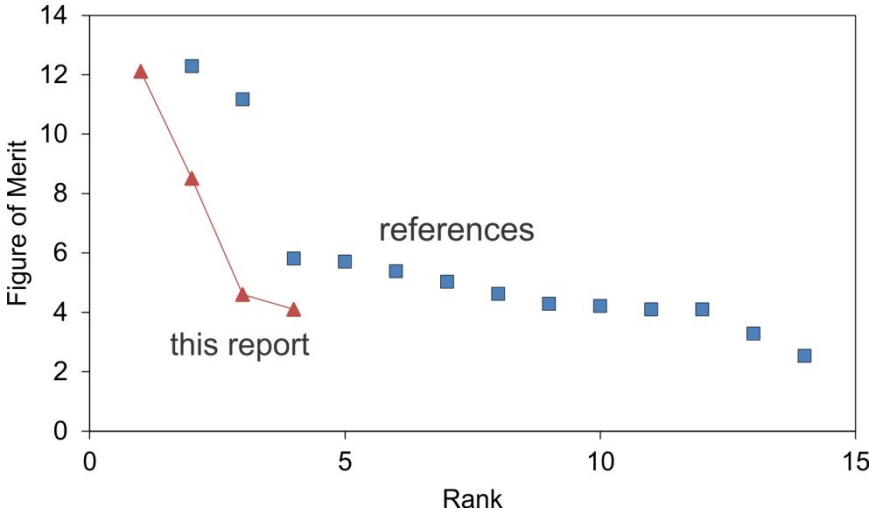


Figure S3. Comparison of the here reported Figure of Merit at different ad-layer coverage to literature values of CVD graphene transferred using $FeCl_3$.¹⁻⁷

Reference

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